7 7 170	Туре	L	# Hit	Search T xt	DBs	Comment s
1	BRS	L1	1454 9	438/\$.ccls.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	
2	BRS	L2	878	<pre>l and (MEMS or microelectromechanica l or (tunable near (FP or fabry-perot) near filter))</pre>		
3	BRS	L3	16	2 and pattern\$3 near (HR or coating)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	
4	BRS	L4	15	3 and (mask or photoresist)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	
5	BRS	L6	45	<pre>(miller-michael-f or le-minh-van or cook-christopher-c or nagle-steven-f).in.</pre>	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	
6	BRS	L7	22	6 and (MEMS or microelectromechanica l or (tunable near (FP or fabry-perot) near filter))	USPAT; US-PGPUB; EPO; JPO; DERWENT, IBM_TDB	,
7	BRS	Ľ8	2	7 and pattern\$3 near (HR or coating)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	
8	BRS	L9	1417	(MEMS or microelectromechanica l or (tunable near (FP or fabry-perot) near filter)).ti.		
9	BRS	L10	346	9 and (mask or photoresist)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	**************************************
10	BRS	L11	0	10 and pattern\$3 near (HR or coating)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	
11	BRS	L12	298	10 and pattern\$3	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	
12	BRS	L13	9638	(MEMS or microelectromechanica l or (tunable near (FP or fabry-perot) near filter))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	,
13	BRS	L14	0	coating)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	
14	BRS	L15	298	12 and (mask or photoresist)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	
15	BRS 1	L16	298	15 and pattern\$3	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	
16	BRS I		0	coating)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	
17	BRS I	17	25	16 and (reflective near coating)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	

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